

## IN THE U.S. PATENT AND TRADEMARK OFFICE

I N F O R M A T I O N S H E E T

Applicant: HYVARINEN, Jaakko  
STENMAN, Folke

Application No.:

Filed: April 27, 2001

For: METHOD AND DEVICE FOR MODIFYING THE IRRADIANCE DISTRIBUTION  
OF A RADIATION SOURCE

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
Finland	04/28/00	20001010

Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP  
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The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH &amp; BIRCH, LLP

By   
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